



PATENT APPLICATION
Docket No. 2522-013
Client No. AW6028US/JS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Tae-Ho Jang Conf. No. 9968
Serial No. 10/076,237 Examiner: Maria F. Guerrero
Filed: February 13, 2002 Art Unit: 2822
For: SILICON-ON-INSULATOR (SOI) SUBSTRATE AND METHOD
 MANUFACTURING THE SAME

MAIL STOP NON FEE AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Responsive to the non-final Office Action dated October 6, 2003, please amend the application as follows.

Amendments to the Claims begin on page 2 of this paper.

Amendments to the Specification begin on page 6 of this paper.

Remarks/Arguments begin on page 7 of this paper.

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Non Fee Amendment Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450
Date: January 5, 2004


Adrienne Chocholak